

# 1996 Index

## IEEE Transactions on Plasma Science

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This index covers all technical items - papers, correspondence, reviews, etc. - that appeared in this periodical during 1996, and items from previous years that were commented upon or corrected in 1996.

The Author Index contains the primary entry for each item, listed under the first author's name, and cross-references from all coauthors. The Subject Index contains several entries for each item under appropriate subject headings, and subject cross-references.

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**Electrostatic processes; cf.** Space charge; Surface charging

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**Submillimeter wave generation**

- orbitron microwave maser in sub-mm microwave radiation. *Alexeff, I.*, +, *T-PS Feb 96* 26

**Submillimeter wave generation; cf. Submillimeter wave oscillators****Submillimeter wave oscillators**

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**Traveling wave devices; cf. Traveling wave tubes****Traveling wave tubes**

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**Underwater technology; cf.** Underwater work systems

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